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CONFIRMATION NO. 8987

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/578,369	05/05/2006	438	1792	127101		
APPLICANTS Syo-ichi Takamizawa, Annaka-shi, JAPAN; Ryuji Sayama, Annaka-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/12179 08/25/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-385333 11/14/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/28/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/BOB M KUNEMUND/</u> Examiner's signature		<input type="checkbox"/> Met after Allowance <u>Initials</u>	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 2	TOTAL CLAIMS 25	INDEPENDENT CLAIMS 2
ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES						
TITLE Method for producing silicon epitaxial wafer						
FILING FEE RECEIVED 1150	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		